



PATENT
Customer No. 22,852
Attorney Docket No. 08245.0027

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Jun Dong KIM et al.

Application No.: 09/892,878

Filed: June 28, 2001

For: METHOD FOR FORMING GATE
ELECTRODES IN A
SEMICONDUCTOR DEVICE
USING FORMED FINE
PATTERNS

)
)
) Group Art Unit: 2814

)
) Examiner: Shrinivas H. Rao

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed July 28, 2003, the period for response having been extended to December 28, 2003 by a request for extension of two months and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment sections of this paper.

FINNEGAN
HENDERSON
FARABOW
GARRETT &
DUNNER ^{LLP}

1300 I Street, NW
Washington, DC 20005
202.408.4000
Fax 202.408.4400
www.finnegan.com